

**LEE0023-US**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:  SHIH-CHANG CHANG ET AL.  Serial No.: NEW APPLICATION  Filed: October 23, 2003  For: SEMICONDUCTOR DEVICE WITH LIGHTLY DOPED DRAIN AND METHOD OF MANUFACTURING THE SAME	Art Unit: Unknown  Examiner: Not Yet Assigned
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**INFORMATION DISCLOSURE STATEMENT ACCOMPANYING FILING**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants wish to make of record in the above-identified application the document or documents referenced on the attached Form PTO-1449. A copy of each reference is enclosed herewith.

It is respectfully requested that the information be expressly considered during the prosecution of this application, and that each reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This submission does not represent that any referenced document is material or constitutes "prior art." If it should be determined that one or more of the referenced documents constitute "prior art" under United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of the reference or references.

Serial No.: NEW APPLICATION  
Art Unit: Unknown

Attorney's Docket No.: LEE0023-US  
Page 2

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over any referenced document, should it be applied against the claims of the present application.

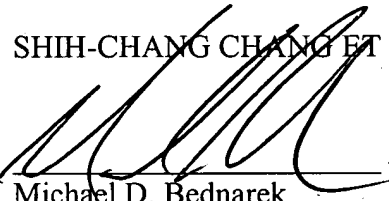
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Date: October 23, 2003

Respectfully submitted,

SHIH-CHANG CHANG ET AL.

By:

  
Michael D. Bednarek  
Registration No. 32,329

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>	ATTY DOCKET NO. <b>LEE0023-US</b>	SERIAL NO. <b>NEW APPLICATION</b>
	<b>SHIH-CHANG CHANG ET AL.</b>	
	FILING <b>OCTOBER 23, 2003</b>	GROUP <b>UNKNOWN</b>

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,306,693	10/23/01	ISHIGURO ET AL.	438	149	09/08/00

**FOREIGN PATENT DOCUMENTS**

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*


<b>EXAMINER</b>	<b>DATE CONSIDERED</b>
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.